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Docket No.: R2184.0307/P307
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masaaki Yoshida et al.

Application No.: 10/803,931

Confirmation No.: 6728

Filed: March 19, 2004

Art Unit: 2891

For: SEMICONDUCTOR DEVICE HAVING A
PLURALITY OF KINDS OF WELLS AND
MANUFACTURING METHOD THEREOF

Examiner: Douglas M. Menz

REQUEST FOR RECONSIDERATION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated October 18, 2006, please reconsider the above-identified U.S. patent application in light of the following.

Claims 1-24 are pending in this application. Claims 9-24 are withdrawn from consideration. Applicants reserve the right to pursue the original and other claims in this and other applications.

Claims 1-8 are rejected under 35 U.S.C. § 102 as being anticipated by Joy. The rejection is respectfully traversed. The claimed invention relates to a semiconductor device with three or more types of wells, in which only one step level difference is